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BIBDATASHEET

CONFIRMATION NO. 7989

| Bib Data Sheet | | | | | | | | | |
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| APPLICANTS | | | | | | | | | |
| Miguel Angel Saldana, Fremont, CA; | | | | | | | | | |
| ** CONTINUING DATA ********************************** | | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/18/2004 | | | | | | | | | |
| Foreign Priority claimed yes 2 yes 2 no 35 USC 119 (a-d) conditions yes 2 no Met after | | | | STATE OR | SHE | HEETS TOTA | | AL | INDEPENDENT |
| met Verified and Acknowledged Movement Signature Alfowance Examiner's Signature Initials | | | | COUNTRY | | WING 6 | CLAIMS 17 | | CLAIMS 4 |
| ADDRESS 25920 MARTINE PENILLA & GENCARELLA, LLP 710 LAKEWAY DRIVE SUITE 200 SUNNYVALE , CA 94085 | | | | | | | | | |
| TITLE Methods with resolution enhancement feature for improving accuracy of conversion of required chemical mechanical polishing pressure to force to be applied by polishing head to wafer | | | | | | | | | |
| RECEIVED | FEES: Authority has been given in P No to charge/credit DEF No for following: | | | aper 'OSIT ACCOU | NT | All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) | | | |
| 856 | | | | | | 1.18 Fees (Issue) | | | |